

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Halahan, Patrick B.; Siniaguine, Oleg
Assignee: Tru-Si Technologies, Inc.
Title: Semiconductor Structures Having Multiple Conductive Layers in an Opening, And Methods For Fabricating Same
Serial No.: Not yet known Filing Date:
Examiner: Not yet known Group Art Unit: Not yet known
Docket No.: M-9999-1D US

San Jose, California
August 28, 2001

Box Patent Application
COMMISSIONER FOR PATENTS
Washington, D. C. 20231

PRELIMINARY AMENDMENT

Dear Sir:

Please amend the above-identified application as follows.

IN THE SPECIFICATION

On page 1, before line 6, please insert the following paragraphs:

CROSS-REFERENCE TO RELATED APPLICATIONS

The present application is a division of U.S. patent application no. 09/792,311 filed February 22, 2001, incorporated herein by reference. ^{now US Patent No. 6,498,381}

IN THE CLAIMS

Please cancel Claims 13-19 and 23-29 without prejudice.

LAW OFFICES OF
SKJERVEN MORRILL
MACPHERSON LLP

25 METRO DRIVE
SUITE 700
SAN JOSE, CA 95110
(408) 433-9200
FAX (408) 433-7979